

Docket No.: 057454-0994

PATENT

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Response Under 37 CFR 1.116 - Expedited Procedure

: Customer Number: 20277

Takeshi SATOH, et al.

: Confirmation Number: 3233

Application No.: 10/750,870

: Group Art Unit: 1754

Filed: January 05, 2004

: Examiner: Edward M. Johnson

For: POROUS Si3 N4 AND PRODUCING METHOD THEREOF

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment Under 37 C.F.R. §1.116 in the above-identified application.

- ☒ No additional fee is required.
☐ Applicant is entitled to small entity status under 37 CFR 1.27
☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	9	20	0	\$50.00 =	\$0.00
Independent Claims	3	3	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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Date: January 23, 2006

Please recognize our Customer No. 20277 as our
correspondence address.

Docket No.: 057454-0994



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Takeshi SATOH, et al.

RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE

Application No.: 10/750,870

Filed: January 05, 2004

Customer No.: 20277
Confirmation No.: 3233

Group Art Unit: 1754

Examiner: Edward M. Johnson

Title: POROUS Si₃N₄ AND PRODUCING METHOD THEREOF

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated October 21, 2005. Please amend the above-identified application as follows.